

In re the Application of: NIHEI, Mizuhisa, et al.

Group Art Unit: 2894

Serial No.: 10/796,146

Examiner: PHAM, Thanhha S.

Filed: March 10, 2004

P.T.O. Confirmation No.: 2043

For. SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

PETITION FOR EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Date: January 5, 2009

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated July 29, 2008 for three months, from October 29, 2008, to January 29, 2009.

The Commissioner is authorized to charge our Deposit Account in the amount of \$980.00 (the amount calculated as \$1,110.00 - \$130.00, previously paid on December 1, 2008) to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

KRATZ, QUINTOS & HANSON, LLP

Donald W. Hanson

Attorney for Applicants

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Reg. No. 27,133

980.00 DA

DWH/evb

Atty. Docket No. 040102 Suite 400 1420 K Street, N.W. Washington, D.C. 20005 (202) 659-2930

PATENT & TRADEMARK OFFICE